

Wire Bonding onto Niobium for **Superconducting Applications Dr. Michael Hamilton, Auburn University** Mike McKeown, Hesse Mechatronics

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Agenda – Wire Bonding onto Niobium

- Reason for this work
- Setup and test conditions
- Bondability and test results
- Conclusions
- Future work



Reason for this work

- Idea started at MTTS in Tampa FL in 2014.
- This initial work is the first of two-three experiments.
- Intial work was with 20 mil Al.
- Reason to use large diameter wire was to reduce induction to help produce nice, clean signals in the 10GHz range.
- Applications include: superconducting of flex cables, data centers, quantum computing, autonomous vehicles, etc.
- Future work will be for 1 mil Al. Project will start soon.



- Nb is great for superconducting applications.
- Nb is a refractory material one that retains its strength at high temperatures.





Setup and Test Conditions

Bonder	DI020 0122			
Bondhead	HBK07-0087			
Bonding temperature	Ambient			
Workholder type	Vacuum clamping			
Software	3.81.13			
Wire	Heraeus 20 mil ALW	-59P BL=500-800 EL=1	2-18%	
Wedge	DeWeyl MISIVG-20-1/8-2.733-70MP			



- Sputter the Nb in a high vacuum.
- Expect that the sputtered films have a columnar growth mode (still needs more characterization).
- Nb seems to be porous reacts with oxygen.
- Nb
- AINb
- AuNb
- All samples were prepared on wafers.
- Thickness layers for AI and the Au were in the 50nm range.
- Nb thickness was in the 250nm range.

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Test Conditions - Touchdown Parameters

	Action S	Settings		Edit Bond Parameters		3.81.12
	Bondjet	BJ939 -	File: 500UM_FC 📑	Source 🖆 📑	Destination 🖆 📑	H&K
0			- Touchdown			
			 Touchdown:	52911 µm	52914 µn	
			Starting height:	[5000 µm		
			Touchdown area:	200 µn	200 µn	re height
			Lower tolerance:		μn	e to Pos.
			Touchdown velocity:	10000 µn/s	10000 m/s	
			Touchdown force:	525.00 cN	525.00 cN	ination
			- Bonding			eters
			□ Shape angle:	0.00 °		500UM_FC
			Overtravel:	500 µm	[500 µn	
			🗖 Pad Locator	Parameters	Parameters	Load
			De l ay :	0 ms	0 ms	Edit
			Turning height:		nu 08 X	
			Angle offset:		0.00 deg	
			TH Overtravel:		пц 100	
			+ Loon			bu stan
						tart
			+ Tear off			
			+ Inline Pull Test			
	F					
	Prod	luction	ОК	Text Export	Cancel	Service
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Test Setup – Looping

Action Settings		Edit Bond Parameters		3.81.12
Bondjet BJ939 -	File: 500UM_FC 📑	Source 🖆 🖹	Destination 🖺 📑	H&K
	 Touchdown Bonding Loop Starting angle: Intermediate height: Intermediate radius: Horizontal distance: Uertical distance: Loop angle: Loop shape source: Close clamp Method: 	70.00 ° 5000 µm 1000 µm 0 µm 0 µm 45.00 ° 20.0 % © Loop height source Cop height destin Apex height	<u>S000</u> μm ⊠ Destination max.	ttings re height to Pos. ce ination eters 500UM_FC Load Edit
♥ + Production	Loop height: Height correction: Loop shape dest.: In Close clamp Intermediate height: Horizontal distance: OK	2000 µm 0.0 X 20.0 X 20.0 X O Uertical © Direct O Arc 0 µm Text Export	Wire length: 8587 µm ✓ Cancel	1 ÷ by step e Wire tart Service

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Test Setup – Bonding Parameters

	Action Settings		Edit Bond Parameters		3.81.12
	Bondjet BJ939 -	File: 500UM_FC 📳	Source 🖆 🖹	Destination 🖆 🖹	H&K
		+ Touchdown			
		+ Bonding			
		- Welding			re height
		Process control:	Const. voltage Const. current	Const. voltage Const. current	e to Pos.
		Stop after deformation:	80.0 X	80.0 X	Ce ination
		Max. welding time:	120 ms	120 ms	
		No. of intervals:	2	2	eters
		Interval:	1		500LIM FC
		Ul trasonic:	20.00 U	20.00 U	
		Bond force:	525.00 cN	525.00 cN	Load
		Duration:	20.0 ms	20.0 ms	Edit
		Ramp:	20.0 ms	20.0 ns	
		Interval:	2	2	
		Ultrasonic:	20.00 U	20.00 U	
		Bond force:	700.00 cN	700.00 cN	
		Duration:	100.0 ms	100.0 ms	by step
		Kamp:	100.0 ms 🖭	100.0 ms 🖃	e Wire
		+ Quality check			tart
		+ Tear off			
	*	+ Inline Pull Test			
Ē	Production	ОК	Text Export	Cancel	Service
	2 1 2				11:47



Test Setup – Bond Head Alignment



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Close up of 1st bonds on AINb



HESSE Close-up 2nd bonds of Al wire on AlNb





Close up of Al wires on AuNb





Bonding onto Nb

- Many instances of non-sticks.
- Need to investigate as to why the high number of nonsticks.
- No instances of contamination.
- Frequency?
- Grain structure?
- Do cross-sectional analysis of parts.







Wire Pull Test Data - AINb

- 20 mil Al wire
- Breaking load of wire was 500 to 800 grams tensile.
- Minimum pull strength is half the tensile 250 grams.
- Mean: 1.2183 kg
- Standard Deviation: 70.284 g



Shear Test Results for AuNb

- Average Shear was 1,566 grams with standard deviation of 161.
- Minimum expected shear is 500 grams.
- Decent nuggets post-shear.



Shear Results - AuNb





Shear Results for AINb

- Average shear was 1,746 grams with a standard deviation of 88.
- Minimum shear value is 500 grams.
- Acceptable nugget post-shear.







- Bonding onto AINb had the best bondability and test results.
- Bonding onto AuNb was 2nd best.
- Bonding onto Nb was not good. Investigating reasons why and will setup a DOE to determine bond parameters.



- Auburn University, Hesse Mechatronics & Fermilab have just started a new experiment with wire bonding fine Al wire onto: Nb; AINb; AuNb.
- NIST in Colorado has been working with Hesse on wire bonding to Nb for quantum computing.
- Applications include microwave amplifiers for the South Pole and Particle Physics ("God-particle").
- Additional testing of heavy AI wire and ribbon will be used in actual parts.



Thank you for your kind attention!

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